Chamber 1
U-
Source material
Sputtered atoms
Inert gas
Glass
Voltage
U+
Stage 1: Pre-coating
Voltage
650
500
.....
Pressure
0.4
0.0
2
4
6
8
10
12
Time
Chamber 2
U-
Source material
Sputtered atoms
U+
Stage 2: Coating
Current
1500
1000
.....
Voltage
800
550
10
20
30
40
50
Time
Chamber 3
U-
Source material
Sputtered atoms
Coated glass
U+
Stage 3: Post-coating
Air flow
1100
0
.....
Current
1170
1020
2
4
6
8
10
12
Time